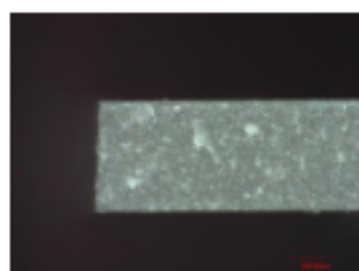
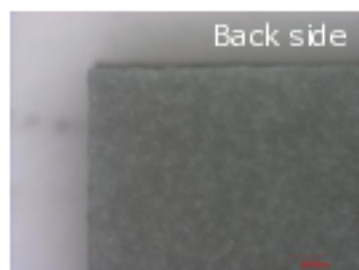
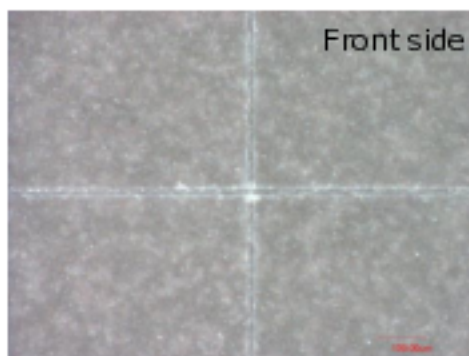


Comparison graph

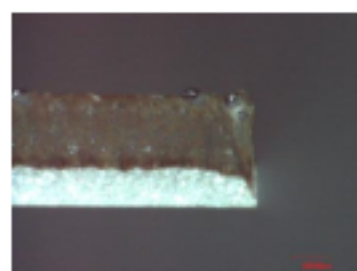
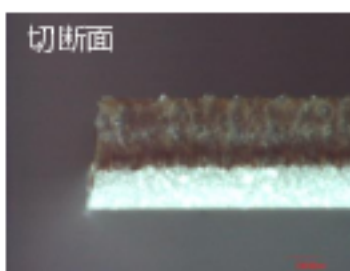
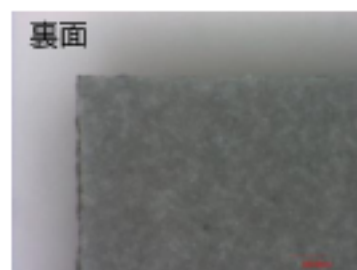
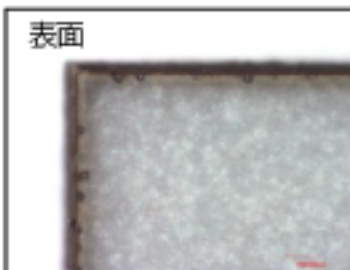
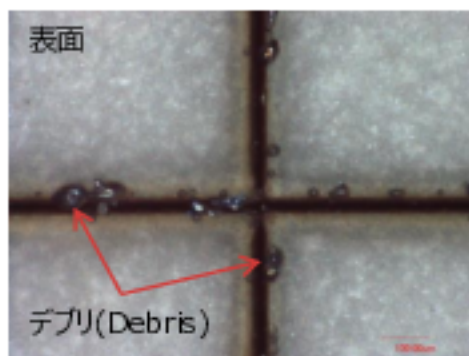
窒化ケイ素 (Si_3N_4) 基板を“Scribe & Break”とレーザで切断加工し比較しました。

Scribe & Break

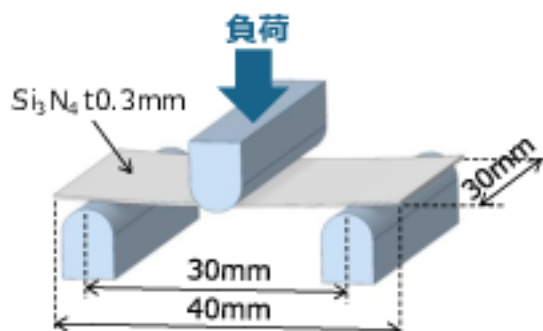
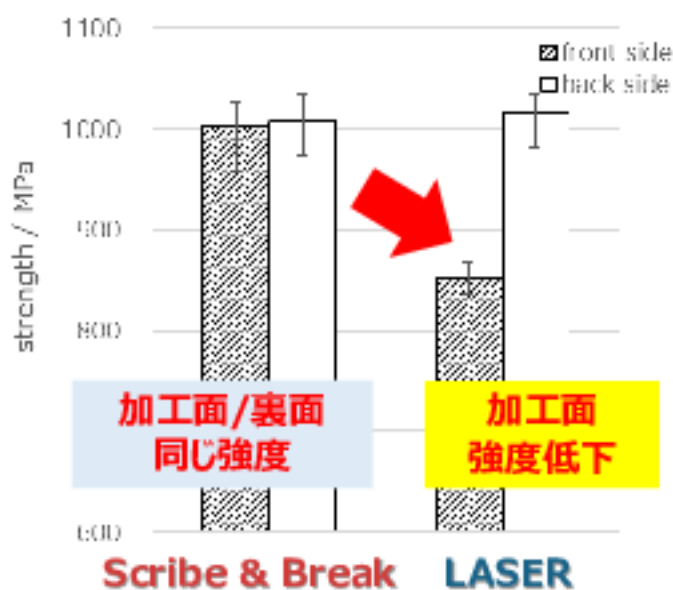


LASER

(Picosec pulse laser)



—3点曲げ試験 (3-point bending test)—



ご質問、ご不明点は下記までお問い合わせください。
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